

INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

ATTY DOCKET NO.
129/015

SERIAL NO. 10/633130
~~To be assigned~~

Fischione et al.

FILING
August 1, 2003

GROUP
1753

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
SHV	3,958,124	5/18/76	Koch et al.	250	44.11	
SHV	5,633,502	5/27/97	Fischione	250	44.11	
SHV	6,190,062	2/20/01	Subramanian et al.	396	578	

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

SHV		Model 682, Precision Etching Coating System (PECS), Gatan Inc., 2001
SHV		Ion Beam Sputter Deposition and Etching System IBS/e, downloaded from the Internet at http://www.southbaytech.com/cgi-bin/homepage/products/view_product.cfm .

EXAMINER

[Signature]

DATE CONSIDERED

August 4, 2005

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

